

35.C14179



PATENT APPLICATION

0500
[Signature]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
YOUICHI ANDO ET AL.)	Examiner: Unassigned
Application No.: 09/722,454)	Group Art Unit: Unassigned
Filed: November 28, 2000)	:
For: METHOD FOR)	
MANUFACTURING	:	
ELECTRON BEAM DEVICE,)	
METHOD FOR	:	
MANUFACTURING IMAGE)	
FORMING APPARATUS,	:	
ELECTRON BEAM DEVICE)	
AND IMAGE FORMING	:	
APPARATUS MANUFACTURED)	
THOSE MANUFACTURING	:	
METHODS, METHOD AND)	
APPARATUS FOR	:	
MANUFACTURING ELECTRON)	
SOURCE AND APPARATUS	:	
FOR MANUFACTURING)	December 21, 2000

Commissioner for Patents
Washington, D.C. 20231

PRELIMINARY AMENDMENT AND
A SEPARATE REQUEST FOR APPROVAL OF DRAWING CHANGES

Sir:

Prior to receipt of the first action on the merits,
kindly amend the subject application as follows: